



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 4, 2026

IGI Report Number

LG823643377

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUT CORNERED
RECTANGULAR MODIFIED
BRILLIANT

Measurements

17.17 X 12.29 X 7.76 MM

GRADING RESULTS

Carat Weight

14.45 CARATS

Color Grade

F

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

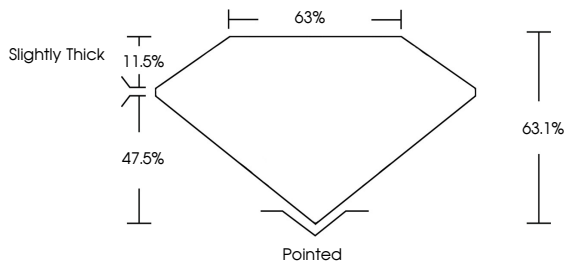
Inscription(s)

 LG823643377

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

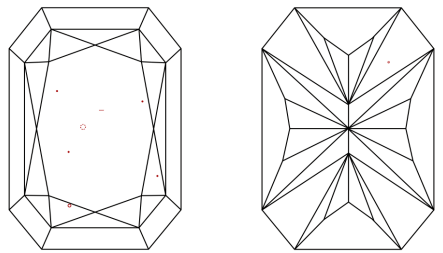
PROPORTIONS



Slightly Thick

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



© IGI 2020, International Gemological Institute



FD - 10 20

LABORATORY GROWN DIAMOND REPORT



August 4, 2026

IGI Report Number

LG823643377

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUT CORNERED
RECTANGULAR MODIFIED
BRILLIANT

Measurements

17.17 X 12.29 X 7.76 MM

GRADING RESULTS

Carat Weight

14.45 CARATS

Color Grade

F

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG823643377

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa



IGI

August 4, 2026

IGI Report No LG823643377

CUT CORNERED RECT. MODIFIED BRILLIANT

17.17 X 12.29 X 7.76 MM

Carat Weight

14.45 CARATS

Color Grade

F

Clarity Grade

VS 1

Depth

63.1%

Table

63%

Girdle

Slightly Thick

Culet

Pointed

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG823643377

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa